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APPLICANTS		And the second s							
Toshihito Tsuga	, Tsuc	hiura-shi, JAPAN;							
Minoru Fube, Ha Kazutaka Nakay		Hayami-gun, JAPAN;	· _ 1					•	
CONTINUING DATA									
JAPAN 2001-059776 03/05/2001									
IF REQUIRED, F ** 03/27/2002	OREK	GN FILING LICENSE O	3RANTE(D					
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						AWING CLAIMS		MS	CLAIMS 2
P O BOX 655474 DALLAS , TX 75265	MENTS	S INCORPORATED 3999							
TITLE Method and devic	e for r	emoving particles on s	emicondu	uctor wafers					
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:				☐ All Fees				
FILING FEE					ıτ	1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time)			
RECEIVED 870					``	1.18 F	ees (Is	sue)	
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